

# LAM 4600 AI Etcher

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## Facts

- The LAM 4600 is a reactive ion etcher for aluminum films.
- The tool is currently plumbed with chlorine, boron trichloride, chloroform, oxygen, and nitrogen

## Personnel

- Tool Engineer - John Nash
- Process Engineer - Sean O'Brien
- Process Engineer - Patricia Meller

## Tool & Process Information

- [Dry Etch Process Information](#)

## Manuals & Users

- [LAM4600 Manual](#)
- [LAM 4600 Certification Checklist](#)